IDS Form PTO/SB/08: Substitute for form 1449A/PTO

Sheet

## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

C	omplete if Known	
Application Number	10/581,497	
Filing Date	June 2, 2006	
First Named Inventor	Babak HEIDARI et al.	
Art Unit	2822	
Examiner Name	Not yet assigned	
Attorney Docket Number	02386.0105	

U.S. PATENTS AND PUBLISHED U.S. PATENT APPLICATIONS						
Examiner Cite No.1		Document Number	Issue or Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where	
	No.'	Number-Kind Code <sup>2</sup> (if known)			Relevant Passages or Relevant Figures Appear	
		US 4,360,266	11-1982	Takeuchi		
		US 5,804,017	09-1998	Hector		
		US 6,190,929	02-2001	Wang et al.		
		US 6,334,960	01-2002	Willson et al.		
		US-6,387,778	05-2002	Bonin et al.		
		US 6,387,787	05-2002	Mancini et al.		
		US 6,743,740	06-2004	Brask		
		US-6,949,199	09-2005	Gauzner et al.		
		US-7,144,539	12-2006	Olsson		
		US 2003-0159608	08-2003	Heidari		
		US 2003-0189273	10-2003	Olsson		
		US 2004-0131718	07-2004	Chou et al.		
		US 2005-0202350	09-2005	Colburn et al.		

Note: Submission of copies of U.S. Patents and published U.S. Patent Applications is not required.

		FORE	GN PATENT	DOCUMENTS			
Examiner Initials	Cite No. <sup>1</sup>	Foreign Patent Document  Country Code <sup>3</sup> Number <sup>4</sup> Kind Code <sup>5</sup> ( <i>if known</i> )	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Translation <sup>6</sup>	
	-	CN 1478642A	03-2004	Zhang Zhehao		Abstract	
	<u>,</u>	JP 2-289311	11-1990	Hoya Corp		Abstract	
		JP 2003-77867	03-2003	Nat Inst of Adv Ind & Technology		Abstract	
		JP 2003-272998	09-2003	Mitsubishi Electric Corp		Abstract	
		JP 2003-516644	05-2003			Abstract	
		DE 36 43817	06-1988	Afga Gevaert AG		Abstract	
		WO 01/33300 A2	05-10-2001	THE UNIVERSITY OF TEXAS AT AUSTIN		N/A	
		WO 02/067055 A2	08-29-2002	BOARD OF REGENTS, THE UNIVERSITY OF TEXAS SYSTEM		N/A	
		WO 03/005124 A1	01-16-2003	OBDUCAT AKTIEBOLAG		N/A	
		NONPATE	NT LITERATI	JRE DOCUMENTS			
Examiner Initials	Cite No.					Translation <sup>6</sup>	
		Heidari et al.; "LARGE SCALE NANOLITHOGRAPHY USING NANOIMPRINT LITHOGRAPHY"; Journal of Vacuum Science & Technology B, Vol. 17, No. 6, pages 2961-2964, (1999)					

Complete if Known IDS Form PTO/SB/08: Substitute for form 1449A/PTO Application Number 10/581,497 Filing Date June 2, 2006 INFORMATION DISCLOSURE First Named Inventor Babak HEIDARI et al. STATEMENT BY APPLICANT Art Unit 2822 Examiner Name Not yet assigned (Use as many sheets as necessary) Attorney Docket Number 02386.0105 2 2 of Sheet

	FOREIGN PATENT D				
	Resnick et al.; "IMPRINT LITHOGRAPHY FOR INTEGRATED CIRCUIT FABRICATION"; Journal of Vacuum Science & Technology B, Vol. 21, No. 6, pages 2624-2631, (2003)				
	English language version of "Notification of the First Offic 200510081756.4, Notification Date June 6, 2008.	ce Action" in corresponding Ch	ninese App. No.		
	English language version of "Notification of the Second 0 200510081756.4, Notification Date October 7, 2009.	Office Action" in corresponding	Chinese App. No.		
Examiner Signature		Date Considered			

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.